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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of **Sherrer**

Application No. 10/790,339

Attorney Docket No.: R&H 04-02; DN 51910 (ACT - 115)

Filed: March 1, 2004

For: MICROSTRUCTURES COMPRISING A
DIELECTRIC LAYER AND A THIN
CONDUCTIVE LAYER

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8(a)

I hereby certify that this Correspondence is being deposited on the date identified below with the United States Postal Service as first-class mail in an envelope properly addressed to Commissioner for Patents, Alexandria, VA 22313-1450

May 27, 2004
Date of Certificate

Cristin Donahue
Cristin Donahue

Commissioner for Patents
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 C.F.R. § 1.97**

In compliance with the duty of disclosure set forth in 37 C.F.R. § 1.56, Applicants are submitting herewith a Form PTO-1449 and a copy of the references listed thereon. This Information Disclosure Statement is being filed within three months of the filing date. Accordingly no fee is required.

Applicants respectfully request full and proper consideration of the listed information during examination of the application, and that the listed information be printed on any patent that issues therefrom.

Respectfully submitted,

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By

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Enclosures - Form PTO-1449

Copies of references listed on PTO - 1449

**INFORMATION
DISCLOSURE
STATEMENT**

Complete if known

Application Number: 10/790,339

Filing Date: March 1, 2004

First Named Inventor: Sherrer

Group Art Unit:

Examiner Name:

SHEET 1 OF 2

Attorney Docket Number: R&H 04-02

UNITED STATES PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	PATENT NUMBER	ISSUE DATE MM-DD-YYYY	FIRST NAMED INVENTOR
		4649630	03/17/1987	Boland et al.
		4853669	08/01/1989	Guckel et al.
		4891984	01/09/1990	Fujii et al.
		4922756	05/08/1990	Henrion
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		5275055	01/04/1994	Zook et al.
		5367217	11/22/1994	Norling
		5417115	05/23/1995	Burns
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		5489556	02/06/1996	Li et al.
		5537083	07/16/1996	Lin et al.
		5594166	01/14/1997	Itoh et al.
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		5808331	09/15/1998	Zhang et al.
		5858809	01/12/1999	Chau et al.
		5866805	02/02/1999	Han et al.
		5870007	02/09/1999	Carr et al.

**EXAMINER'S
SIGNATURE**

**DATE
CONSIDERED**

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP §609. Draw a line through citation if citation not in conformance and reference not considered. Include a copy of this form with next communication to applicant.

INFORMATION DISCLOSURE STATEMENT	<i>Complete if known</i>
	Application Number: 10/790,339
	Filing Date: March 1, 2004
	First Named Inventor: Sherrer
	Group Art Unit:
Examiner Name:	
SHEET 2 OF 2	Attorney Docket Number: R&H 04-02

		5883310	03/16/1999	Ho et al.
		5922212	07/13/1999	Kano et al.
		5936159	08/10/1999	Kano et al.
		5943155	08/24/1999	Goosen
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		5973394	10/26/1999	Slocum et al.
		5987989	11/23/1999	Yamamoto et al.
		6012336	01/11/2000	Eaton et al.
		6090665	07/18/2000	Kerber
		6146917	11/14/2000	Zhang et al.
		6238935	05/29/2001	Egley et al.

FOREIGN PATENT DOCUMENTS					
EXAMINER'S INITIALS	CITE NO.	DOCUMENT NUMBER	COUNTRY OR REGION	DATE OF PUBLICATION MM-DD-YYYY	FIRST NAMED INVENTOR OR APPLICANT

OTHER PRIOR ART - NON-PATENT DOCUMENTS		
EXAMINER'S INITIALS	CITE NO.	Include name of the author (in Capital Letters), title of the article (when appropriate), title of the item(book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published

EXAMINER'S SIGNATURE		DATE CONSIDERED	
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